

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/595,778 Confirmation No: 6490	Examiner: Allan W. Olsen
Filed: June 16, 2000	Attorney Docket No: 2077 USA D01/ETCH/SILICON/MDD
Title: APPARATUS AND METHOD FOR MONITORING PROCESSING OF A SUBSTRATE	September 16, 2008 San Francisco, California

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

VIA EFS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner Olsen:

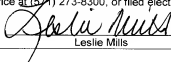
This communication is in response to Notice of Non-Compliant Amendment dated August 28, 2008, and is being timely filed within one month.

The Notice indicated that the Amendments to the claims were non-compliant because they were made relative to the amendment dated February 19, 2008, and not relative to the after-final amendment dated March 27, 2008. This has been rectified, and the claims are re-submitted herewith.

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, facsimile transmitted to the U.S. Patent Office at (571) 273-8300, or filed electronically via EFS on the date shown below

By:


Leslie Mills

Date: September 16, 2008